

635.43483X00

IFW

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Applicants: S. KADLEC, et al.

Serial No.: 10/798,331

Filed: March 12, 2004

For: METHOD FOR MANUFACTURING SPUTTER-COATED

SUBSTRATES, MAGNETRON SOURCE AND SPUTTERING

CHAMBER WITH SUCH SOURCE

INFORMATION DISCLOSURE STATEMENT UNDER 37 CFR 1.97 & 1.98

Commissioner for Patents P.O. Box 1450 Alexandria, VA 22313-1450

October 7, 2005

Sir:

In the matter of the above-identified application, applicants are submitting herewith for the Examiner's consideration copies of documents cited in a communication from a foreign patent office in a counterpart foreign application. The documents are listed on the attached form equivalent to Form PTO-1449.

This information disclosure statement is being submitted before the mailing date of a first office action on the merits.

Each of the documents listed on the attached form equivalent to Form PTO-1449 is in the English language.

It is respectfully requested that this information disclosure statement be considered by the Examiner.

Please charge any shortage in the fees due in connection with the

filing of this paper, including extension of time fees, to the deposit account of Antonelli, Terry, Stout & Kraus, LLP, Deposit Account No. 01-2135 (Case: 635.43483X00), and please credit any excess fees to such deposit account.

Respectfully submitted,

ANTONELLI, TERRY, STOUT & KRAUS, LLP

Ronald J. Shore

Registration No. 28,577

RJS/kmh (703) 312-6600 Attachments Sheet 1 of 1

Form PTO-144

TRADE ATEN

Form PTO-144 DEPARTMENT OF COMMERCE ATENT AND TRADEMARK OFFICE	ATTY. DKT. NO. 635,43483X00	SERIAL NO. 10/798,331		
INFORMATION DISCLOSURE STATEMENT	APPLICANT S. KADLEC, et al.			
BY APPLICANT (Use several sheets if necessary)	FILING DATE March 12, 2004	GROUP		

U.S. PATENT DOCUMENTS

Examiner Initial		Document Number	Date	Name	Class	Subclass	Filing Date
	AA	2004/00207 68 A1	02/05/04	Wang et al.			08/01/02
	AB	2004/00356 92 A1	02/26/04	Ding et al.			08/22/03
	AC	6,491,801 B1	12/10/02	Gung			08/07/01
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FOREIGN PATENT DOCUMENTS

Examiner Initial		Document Number Date	Country	Class	Subclass	Translation /Abstract		
							Yes	No
	AM	EP 1 067 577 A	01/10/01	Europe				
	AN	WO 2004/01735 6 A2	02/26/04	PCT				
	AO							
	AP							
	AQ							
	AR							
	AS							
	AT							

OTHER DOCUMENTS (Including Author, Title, Date, Pertinent Pages, Etc.)

AU	"The unbalanced magnetron: current status of development" SURFACE AND COATING TECHNOLOGY, vol. 48, no. 1, October 1, 1991 pages 81-94.				
AV	International Search Report; PCT/CH2005/000006; Filing Date: 01/06/05				
AW					
AX					
AY					
AZ					
Examiner	Date Considered				